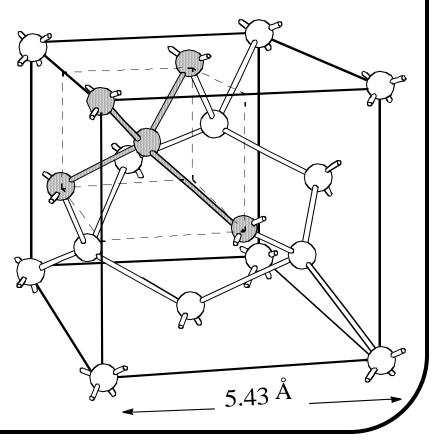
Chapter 1 Electrons and Holes in Semiconductors

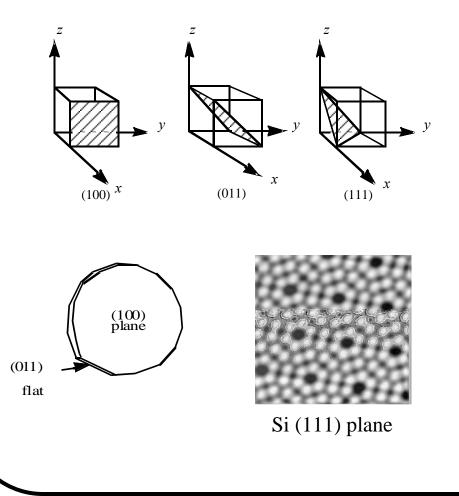
1.1 Silicon Crystal Structure

- *Unit cell* of silicon crystal is cubic.
- Each Si atom has 4 nearest neighbors.



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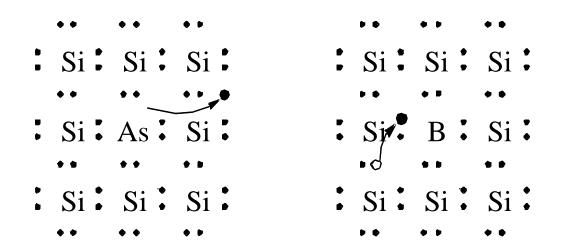
Silicon Wafers and Crystal Planes



- The standard notation for crystal planes is based on the cubic unit cell.
- Silicon wafers are usually cut along the (100) plane with a flat or notch to help orient the wafer during IC fabrication.

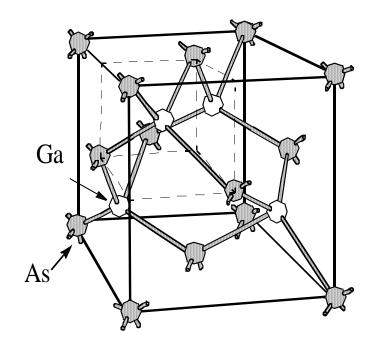
Si Si Si Si Si Si Si Si Si Si	·· ·· Si Si Si	si Si Si	1.2	••• ••	<i>Iodel of E</i> Si : Si : Si : Si : Si : Si :	• Silicon crystal in a two-dimensional representation.
				• •	• •	

Dopants in Silicon



- As, a Group V element, introduces conduction electrons and creates *N-type silicon*, and is called a *donor*.
- B, a Group III element, introduces holes and creates *P-type silicon*, and is called an *acceptor*.
- Donors and acceptors are known as dopants. Dopant ionization energy ~50meV (very low). Hydrogen: $E_{ion} = \frac{m_0 q^4}{8\varepsilon_0^2 h^2} = 13.6 \text{ eV}$

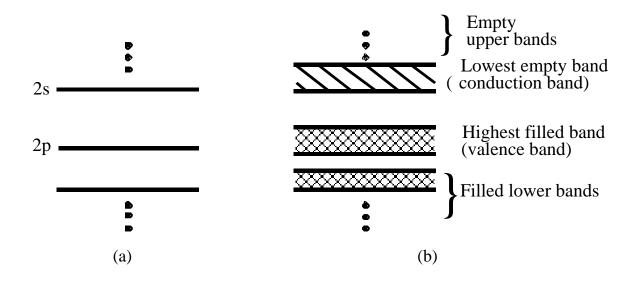
GaAs, III-V Compound Semiconductors, and Their Dopants



Ga: As : Ga: As: Ga: As: Ga: As : Ga:

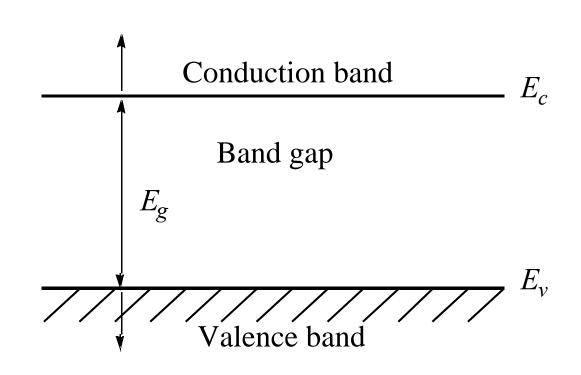
- GaAs has the same crystal structure as Si.
- GaAs, GaP, GaN are III-V compound semiconductors, important for optoelectronics.
- Which group of elements are candidates for donors? acceptors?

1.3 Energy Band Model



- Energy states of Si atom (a) expand into energy bands of Si crystal (b).
- The lower bands are filled and higher bands are empty in a semiconductor.
- The highest filled band is the *valence band*.
- The lowest empty band is the *conduction band*.

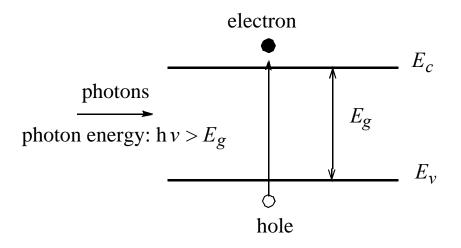
1.3.1 Energy Band Diagram



• *Energy band diagram* shows the bottom edge of conduction band, E_c , and top edge of valence band, E_v .

• E_c and E_v are separated by the **band gap energy**, E_g .

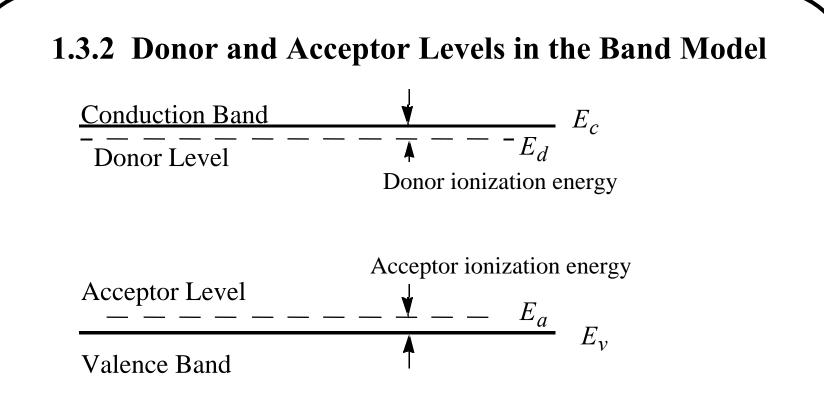
Measuring the Band Gap Energy by Light Absorption



• E_g can be determined from the minimum energy (hv) of photons that are absorbed by the semiconductor.

Bandgap energies of selected semiconductors

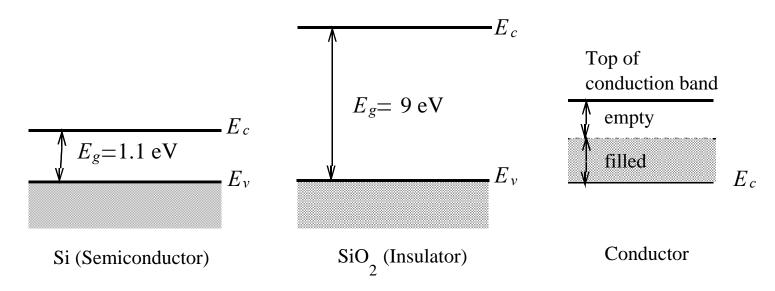
Semiconductor	PbTe	Ge	Si	GaAs	GaP	Diamond
E_g (eV)	0.31	0.67	1.12	1.42	2.25	6.0



Ionization energy of selected donors and acceptors in silicon

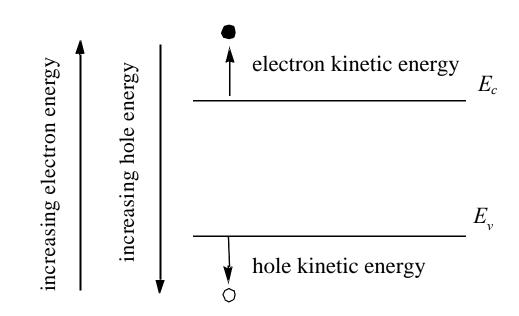
	Donors			Acceptors		
Dopant	Sb	Р	As	В	Al	In
Ionization energy, $E_c - E_d$ or $E_a - E_v$ (meV)	39	44	54	45	57	160

1.4 Semiconductors, Insulators, and Conductors



- Totally filled bands and totally empty bands do not allow current flow. (Just as there is no motion of liquid in a totally filled or totally empty bottle.)
- Metal conduction band is half-filled.
- Semiconductors have lower E_g 's than insulators and can be doped.

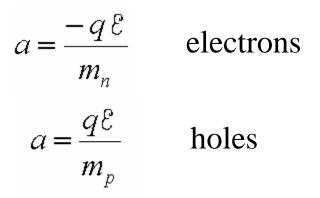
1.5 Electrons and Holes



- Both electrons and holes tend to seek their lowest energy positions.
- Electrons tend to fall in the energy band diagram.
- Holes float up like bubbles in water.

1.5.1 Effective Mass

In an electric field, \mathcal{E} , an electron or a hole accelerates.



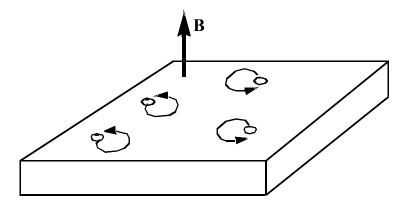
Electron and hole effective masses

	Si	Ge	GaAs	GaP
m_n/m_0	0.26	0.12	0.068	0.82
m_p/m_0	0.39	0.30	0.50	0.60

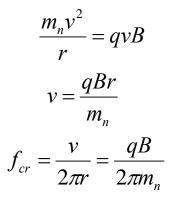
1.5.2 How to Measure the Effective Mass

Cyclotron Resonance Technique

Centripetal force = Lorentzian force

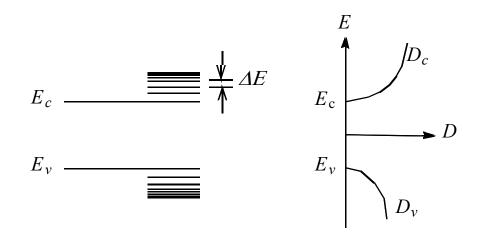






 f_{cr} is the Cyclotron resonance frequency. It is independent of v and r. Electrons strongly absorb microwaves of that frequency. By measuring f_{cr} , m_n can be found.

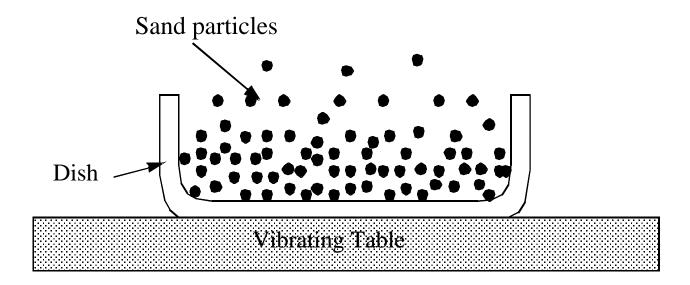
1.6 Density of States



$$D_{c}(E) = \frac{\text{number of states in } \Delta E}{\Delta E \cdot \text{volume}} \left(\frac{1}{\text{eV} \cdot \text{cm}^{3}}\right)$$
$$D_{c}(E) = \frac{8\pi m_{n}\sqrt{2m_{n}(E - E_{c})}}{h^{3}}$$
$$D_{v}(E) = \frac{8\pi m_{p}\sqrt{2m_{p}(E_{v} - E)}}{h^{3}}$$

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1.7 Thermal Equilibrium 1.7.1 An Analogy for Thermal Equilibrium



• There is a certain probability for the electrons in the conduction band to occupy high-energy states under the agitation of thermal energy (vibrating atoms, etc.)

1.7.2 Fermi Function–The Probability of an Energy State Being Occupied by an Electron

$$f(E) = \frac{1}{1 + e^{(E - E_f)/kT}}$$

 $f(E) \approx e^{-(E-E_f)/kT}$

0.5

f(E)

E

 $E_f + 3kT$ $E_{f_{i}} + 2kT$

 $\begin{array}{c} E_f + kT \\ E_f \end{array}$

 $E_{f} - kT$

 $E_f - 2kT$

 $E_f - 3kT$

 E_f is called the *Fermi energy* or the *Fermi level*.

Boltzmann approximation:

$$f(E) \approx e^{-(E-E_f)/kT}$$
 E

$$E - E_f >> kT$$

$$f(E) \approx 1 - e^{-(E_f - E)/kT} \quad E - E_f << -kT$$

Remember: there is only $\int f(E) \approx 1 - e^{-(E_f - E)/kT}$ one Fermi-level in a system at equilibrium.

1.8 Electron and Hole Concentrations1.8.1 Derivation of *n* and *p* from *D*(*E*) and *f*(*E*)

$$n = \int_{E_c}^{\text{top of conduction band}} f(E) D_c(E) dE$$

$$n = \frac{8\pi m_n \sqrt{2m_n}}{h^3} \int_{E_c}^{\infty} \sqrt{E - E_c} e^{-(E - E_f)/kT} dE$$

$$=\frac{8\pi m_n \sqrt{2m_n}}{h^3} e^{-(E_c - E_f)/kT} \int_0^\infty \sqrt{E - E_c} e^{-(E - E_c)/kT} dE$$

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Electron and Hole Concentrations

$$n = N_c e^{-(E_c - E_f)/kT}$$

$$N_c \equiv 2 \left[\frac{2\pi m_n kT}{h^2} \right]^{3/2}$$

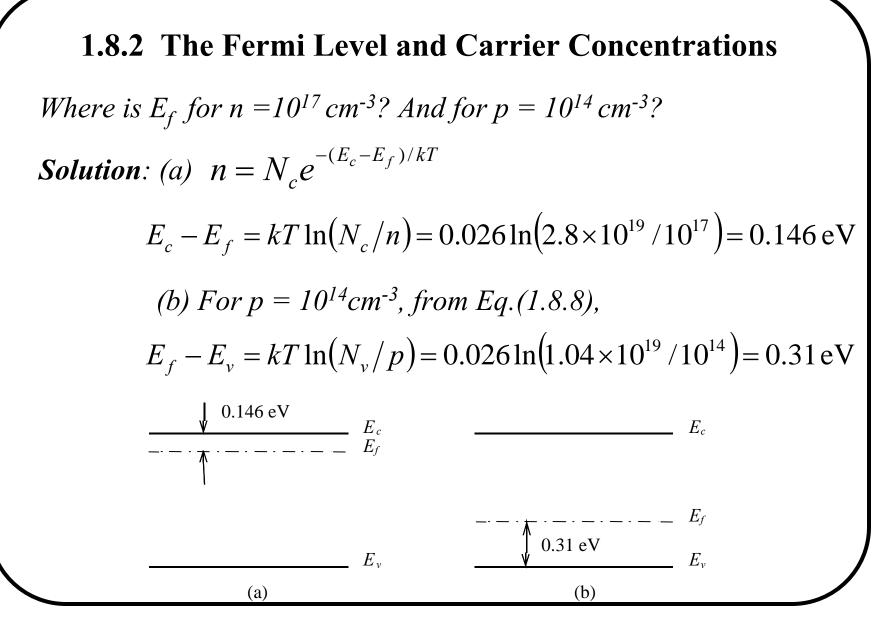
$$p = N_{v}e^{-(E_{f}-E_{v})/kT}$$

$$N_{v} \equiv 2 \left[\frac{2\pi m_{p} kT}{h^{2}} \right]^{3/2}$$

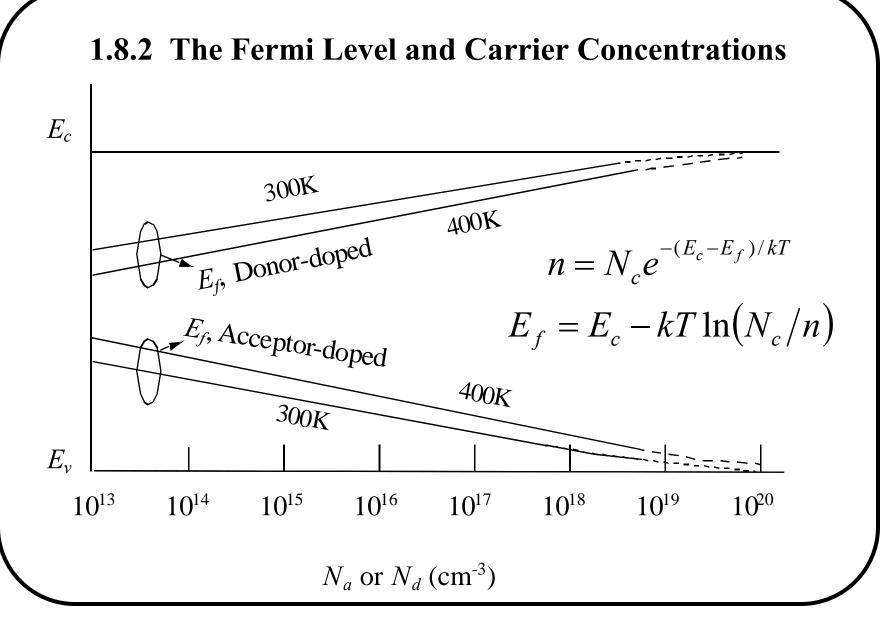
 N_c is called the *effective* density of states (of the conduction band).

 N_v is called the *effective* density of states of the valence band.

Remember: the closer E_f moves up to N_c , the larger *n* is; the closer E_f moves down to N_v , the larger *p* is. For Si, $N_c = 2.8 \times 10^{19}$ cm⁻³ and $N_v = 1.04 \times 10^{19}$ cm⁻³.



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1.8.3 The np Product and the Intrinsic Carrier Concentration

Multiply
$$n = N_c e^{-(E_c - E_f)/kT}$$
 and $p = N_v e^{-(E_f - E_v)/kT}$

$$np = N_c N_v e^{-(E_c - E_v)/kT} = N_c N_v e^{-E_g/kT}$$

$$np = n_i^2$$

$$n_i = \sqrt{N_c N_v} e^{-E_g/2kT}$$

- In an intrinsic (undoped) semiconductor, $n = p = n_i$.
- n_i is the *intrinsic carrier concentration*, ~10¹⁰ cm⁻³ for Si.

EXAMPLE: Carrier Concentrations

Question: What is the hole concentration in an N-type semiconductor with 10^{15} cm⁻³ of donors?

Solution: $n = 10^{15} \text{ cm}^{-3}$.

$$p = \frac{n_i^2}{n} \approx \frac{10^{20} \text{ cm}^{-3}}{10^{15} \text{ cm}^{-3}} = 10^5 \text{ cm}^{-3}$$

After increasing T by 60 °C, n remains the same at 10^{15} cm⁻³ while p increases by about a factor of 2300 because $n_i^2 \propto e^{-E_g/kT}$.

Question: What is n if $p = 10^{17}$ cm⁻³ in a P-type silicon wafer?

Solution:

$$n = \frac{n_i^2}{p} \approx \frac{10^{20} \text{ cm}^{-3}}{10^{17} \text{ cm}^{-3}} = 10^3 \text{ cm}^{-3}$$

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EXAMPLE: Complete ionization of the dopant atoms

 $N_d = 10^{17}$ cm⁻³. What fraction of the donors are not ionized?

Solution: First assume that all the donors are ionized.

$$n = N_d = 10^{17} \text{ cm}^{-3} \Rightarrow E_f = E_c - 146 \text{meV}$$

$$\xrightarrow{45 \text{meV}}_{146 \text{meV}}_{146 \text{meV}}_{166 \text{meV}$$

Therefore, it is reasonable to assume complete ionization, i.e., $n = N_d$.

1.9 General Effects of Doping on n and p

Charge neutrality: $n + N_a = p + N_d$

$$np = n_i^2$$

$$p = \frac{N_a - N_d}{2} + \left[\left(\frac{N_a - N_d}{2} \right)^2 + n_i^2 \right]^{1/2}$$
$$n = \frac{N_d - N_a}{2} + \left[\left(\frac{N_d - N_a}{2} \right)^2 + n_i^2 \right]^{1/2}$$

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1.9 General Effects of Doping on n and p

I.
$$N_d - N_a >> n_i$$
 (i.e., N-type)
 $n = N_d - N_a$
 $p = n_i^2/n$

If $N_d \gg N_a$, $n = N_d$ and $p = n_i^2 / N_d$

II.
$$N_a - N_d >> n_i$$
 (i.e., P-type) $p = N_a - N_d$
 $n = n_i^2 / p$

If
$$N_a >> N_d$$
, $p = N_a$ and $n = n_i^2 / N_a$

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EXAMPLE: Dopant Compensation

What are n and p in Si with (a) $N_d = 6 \times 10^{16} \text{ cm}^{-3}$ and $N_a = 2 \times 10^{16} \text{ cm}^{-3}$ and (b) additional $6 \times 10^{16} \text{ cm}^{-3}$ of N_a ?

(a)
$$n = N_d - N_a = 4 \times 10^{16} \text{ cm}^{-3}$$

 $p = n_i^2 / n = 10^{20} / 4 \times 10^{16} = 2.5 \times 10^3 \text{ cm}^{-3}$
(b) $N_a = 2 \times 10^{16} + 6 \times 10^{16} = 8 \times 10^{16} \text{ cm}^{-3} > N_d!$
 $p = N_a - N_d = 8 \times 10^{16} - 6 \times 10^{16} = 2 \times 10^{16} \text{ cm}^{-3}$
 $n = n_i^2 / p = 10^{20} / 2 \times 10^{16} = 5 \times 10^3 \text{ cm}^{-3}$
 $\stackrel{\bullet \bullet \bullet}{=} \frac{n = 4 \times 10^{16} \text{ cm}^{-3}}{n = 6 \times 10^{16} \text{ cm}^{-3}}$

 $N_a = 2 \times 10^{16} \text{ cm}^{-3}$

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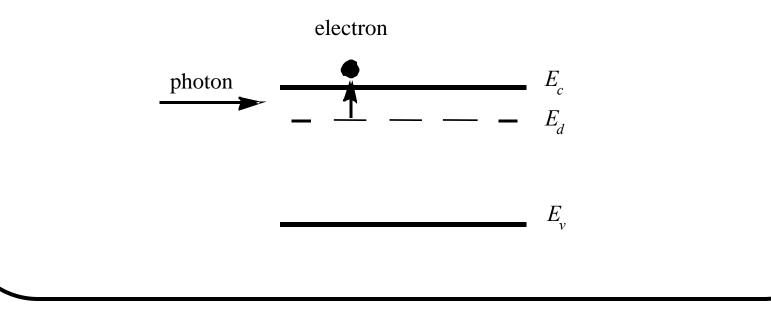
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 $N_a = 8 \times 10^{16} \text{ cm}^{-3}$

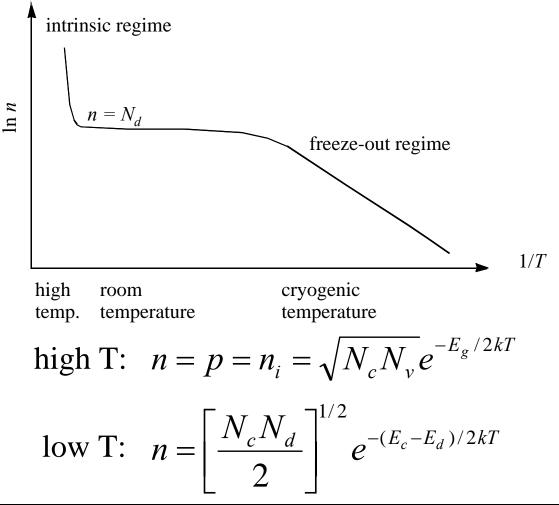
 $p = 2 \times 10^{16} \text{ cm}^{-3}$

Infrared Detector Based on Freeze-out

To image the black-body radiation emitted by tumors requires a photodetector that responds to hv's around 0.1 eV. In doped Si operating in the freeze-out mode, conduction electrons are created when the infrared photons provide the energy to ionized the donor atoms.



1.10 Carrier Concentrations at Extremely High and Low Temperatures



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1.11 Chapter Summary

Energy band diagram. Acceptor. Donor. m_n, m_p . Fermi function. E_{f} .

$$n = N_c e^{-(E_c - E_f)/kT}$$
$$p = N_v e^{-(E_f - E_v)/kT}$$

$$n = N_d - N_a$$
$$p = N_a - N_d$$

$$np = n_i^2$$

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